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SEP 2 9 2004 E

September 27 2004 Roberta A. Winzeler
Roberta A. Winzeler
(Name)
Roberts A. Winseles
(Signature)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: JULIA MACLACHLAN) GROUP ART UNIT: 1733
Serial No.: 09/997,347) Examiner: Jessica L. Ross
Filing Date: November 29, 2001) Attorney Docket: 1-15092
For: METHOD OF USING SHORT WAVELENGTH)
UV LIGHT TO SELECTIVELY REMOVE A COATING)
FROM A SUBSTRATE AND ARTICLE PRODUCED)
THEREBY)

September 17, 2004

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

DECLARATION UNDER 37 C.F.R. §1.131

Honorable Sir:

- I, Julia B. MacLachlan declare as follows:
- I am the inventor of the pending claims of the above-identified patent application.
 I am currently, and have at all times relevant hereto, been employed by Pilkington North
 America, Inc., the assignee of the subject application.
- 2. This declaration is to establish completion of the invention in this application in the United States at a date prior to February 8, 2001, the earliest filing date of an application related to Published U.S. Patent Application No. 2003/0024180 to Hartig et al.

3. Prior to February 8, 2001, I conceived the idea of a method for removing a hydrophobic coating from a glass substrate by exposing said coating to short wavelength UV light.

In this regard, a true copy of an invention disclosure document authored by me prior to February 8, 2001 with the actual date redacted is attached as Exhibit A.

- 4. Prior to February 8, 2001, I conducted experiments related to the removal of hydrophobic coatings from a glass substrate which were recorded in lab notebook 795. In this regard, attached are true copies of p129 477 as Exhibit B. From these experiments, I was able to author the document referred to in paragraph 3, herein.
- 5. Prior to February 8, 2001 Ushio, the supplier of the UV light source utilized by applicant, conducted certain testing on samples having hydrophobic coatings thereon. The samples upon which Ushio performed its tests were provided by PNA. Ushio's tests showed significant change in contact angle. The results were recorded at Ushio report Irradiation test Pilkington Tech. Sept. 20002.xls (Exhibit C).
- 6. Thus, prior to February 8, 2001, I reduced to practice the method to remove hydrophobic coatings using short wavelength UV light disclosed in the above-captioned application.
- 7. Tests regarding the differences in adhesion of an item to glass treated with short wave-length UV light were conducted at my direction prior to February 8, 2001 as shown in Exhibit D attached hereto.
- 8. The undersigned further declares that all statements made herein of my own knowledge are true, and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section

1001 of title 18 of the United States Code, and that such willful false statements may je	opardize
the validity of the application or any patent issuing thereon.	

Date: 9/17/04

Julia B. MacLachlan



LIBBEY-OWENS-FORD CO.

DISCLOSURE AND RECORD OF INVENTION

Julia MacLachlan	
Position of discloser:	
Senior Scientist	·
Department or plant	
Glazing Systems, Plant 21	
Use of very short wave UV light (172nm) to coating from glass	or selective removal of hydropho
coating from glass	or selective removal of hydropho
Use of very short wave UV light (172nm) to coating from glass Inventor(s) Name and Address: Julia MacLachlan 7041 Blossman Drive, Toledo, OH43617	or selective removal of hydropho
Inventor(s) Name and Address:	or selective removal of hydropho
Inventor(s) Name and Address:	or selective removal of hydropho
Inventor(s) Name and Address: Julia MacLachlan 7041 Blossman Drive, Toledo, OH43617	or selective removal of hydropho

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PILKINGTON LIBBEY-OWENS-FORD CO.

DISCLOSURE AND RECORD OF INVENTION

	6/22/00 Sam Sahi 7/12/00 Jeff Williams (Lathom)
	7/1700 George Bukovinszky
	7/19/00 Scott Chambers While the (Applied Laser Technology)
l	7/19/00 Steve Knight (Applied Laser Technology)
3.	First sketch (give date and attach a copy):
	7/24/00 Letter to Steve Knight
9.	First written description (give date and attach a copy):
	As #8
	AS # 0
10.	Date of completion of first device or material:
	6/28/00 Testing of 1065nm laser at PNA Technical Center (unsuccessful)
	a 10/100 Testing of 2/18 nm laser at Applied Laser Technology (disabout 150mm)
	o to 5 to 0. Tenting of 172 nm lamp at Ushio (Japan) (Successsiui)
	9/25/00 Testing of 172nm lamp at Ushio (Japan) (successsful)
	9/25/00 Testing of 172nm lamp at Ushio (Japan) (successsion)
11.	9/25/00 Testing of 172nm lamp at Ushio (Japan) (successsion) First test of invention (give date and general result):
11.	9/25/00 Testing of 172nm lamp at Ushio (Japan) (successsion) First test of invention (give date and general result):
11.	9/25/00 Testing of 172nm lamp at Ushio (Japan) (successsion) First test of invention (give date and general result): 9/25/00 Measurement of water contact angle on treated samples at Ushio Japan – water contact angle was reduced from around 110° to 10-25° by treatment. Report
11.	9/25/00 Testing of 172nm lamp at Ushio (Japan) (successful) First test of invention (give date and general result):
11.	9/25/00 Testing of 172nm lamp at Ushio (Japan) (successsion) First test of invention (give date and general result): 9/25/00 Measurement of water contact angle on treated samples at Ushio Japan — water contact angle was reduced from around 110° to 10-25° by treatment. Report received by e-mail from Ushio America, Inc.
11.	9/25/00 Testing of 172nm lamp at Ushio (Japan) (successsion) First test of invention (give date and general result): 9/25/00 Measurement of water contact angle on treated samples at Ushio Japan — water contact angle was reduced from around 110° to 10-25° by treatment. Report received by e-mail from Ushio America, Inc.

LIBBEY-OWENS-FORD CO.

DISCLOSURE AND RECORD OF INVENTION

	Kameda (Ushio Japan).
	First commercial use, if any:
	Drawing, photograph, notebook page, report or order numbers:
•	Irradiation Test Pilkingston Tech.Sept.20002.xls received by e-mail from Ushio Japan. Dated print outs (6/22/00) of related information from Internet.
	, supreme and a second
	Purpose of invention (include, if known, what has been suggested and used before

Selective removal of hydrophobic coating from glass in order to be able to bond structural adhesives or encapsulation material to the glass in this area. Currently glass is masked prior to coating in areas to be bonded. Work at NSG used plasma etching to try to remove the coating but the cycle times were slow and it was not possible to remove coating from ground edge of glass. A further alternative is the use of chemical etchants to remove the hydrophobic layer, but there are numerous health and safety issues associated with the extremely aggressive chemicals required for this.

Complete description of invention. Include: (a) advantages of invention and how it is distinguished from what is old; (b) description of any known or potential commercial applications of the invention in the Company's operations; (c) description of any known or potential licensing opportunities.

172nm laser light has been used (in academic institutions, initially Johannes



PILKINGTON LIBBEY-OWENS-FORD CO.

DISCLOSURE AND RECORD OF INVENTION

Kepler University in Linz, Austria) to etch the surface of Teflon in order to increase its surface energy to make it easier to facilitate bonding. This wavelength is used because it gives the correct energy to break a C-F bond. The outer layer of hydrophobic coatings usually consists of a long chain fluorosilane. The C-F bonds contained therein should also be susceptible to cleavage by 172nm light. Lasers of this wavelength are not yet commercially available so other wavelengths were tested which were available locally or from custom laser shops. However, these were not successful so a source of UV lamps with high intensity at this wavelength was located. Initial testing by Ushio Japan gave a significant reduction in water contact angle implying an increase in surface energy at short exposure times. Future work will concentrate on adhesion testing of treated samples, treating of ground edge of glass, increasing light intensity to further reduce cycle times and automation of the process. If this is successful this process could eliminate the need for masking of the glass prior to coating, which is very labour intensive.

Discloser: Julia Naclachia Date: 2.10.00 Witness: Date: 2.10.00
Patent Committee Action:
Date:

LIBBEY-OWENS-FORD COMPANY · Research Department		
LABORATORY NOTEBOOK	No	1294
Subject Hydrophobic Romard Using Title Laser Light.	Project No	. 557 a
OBJECTIVE: References in literature suggest of 1744mm laser whit see apply 1 Tellan to increase surface energy	12/2	NATURE AND 3/00
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or testing on Internet But Applied Fech (see opp.) are a laber job a & believed they had the correct e	wicho 1 Lou 1 Cop 1 Cop	rent
to get any effect on coating	tob,	rpe squ

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Y-OWENS-FORD COMPANY · Research Department No 129477 LABORATORY NOTEBOOK Hydrophobic Pomoral varg Project No. 55714 Laser Light 12/23/00 DATE Tellan to uncrease surface every ternet search on laver of etching unpopular with after seeing som sahis use of pp) to try of etch. gas for sam used som used 1064 nm whit but was not ble to get any effect on contine despute soars different unto steep & exposure times and not find 174mm lave for purchase testing on Internet. But Applied labor sech (see opp.) are a labor job shop believed they had the correct equipment abever the evertest uswellingth avoilable as aftern but A.L.T. where not able a get any effect on coature

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	- Journal Entry — Anthony Trollope Thoughts & Ideas	Wednesday August 2000
	Applied japer tech: Fried	Veek 32
	Sterm to mer	

ONS.

NA

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TAPED IN LAB NOTEBOOK

NS.9
ECONOMICAL SURFACE MODIFICATION OF FLUOROCARBON RESIN FOR HYDROPHILIC PROPERTY WITH PRELIMINARY MODIFICATION BY USING 172nm Xe, ** EXCIMER LAMP. Ken Hatao* and Masataka Murahara**; *Tokai University, **Faculty of Electrical Engineering, Tokai University, Kanagawa, JAPAN.

Vluorocarbon resin is chemically a high stable polymer that consists of C F bonds. It has excellent properties of electric insulation, thermal and chemical resistance. With these properties, it is noticed for its possibility of applications as compound materials such as a high voltage resistance compound material and high frequency print circuit board. However, its surface repels both oil and water and has poor adhesion. We have photochemically modified a fluorocarbon resin surface into hydrophilic by using ArF excimer laser in order to improve its adhesive strength. In this paper, for simpler and safer modification, we successfully demonstrated a more efficient surface modification of fluorocarbon resin with a preliminary treatment. Water or B(OH)₃ solution dropped on a fluorocarbon resin surface, which was covered with a fused silica glass to form a thin layer by a capillary phenomenon. Then, 172nm Xe₂* excimer lamp light irradiated perpendicular to the interface between the fluorocarbon resin and the reaction solution to modify preliminary. The fused silica glass was removed, and water or B(OH)₃ was exclusively dropped onto the irradiation area; which was irradiated with ArF excimer laser (wavelength =193nm) perpendicularly. The hydrophilic property of the modified surface was evaluated by measurements of contact angle with water. With preliminary modification time of three minutes, ArF excimer laser fluence of 10mJ/cm² and laser shot number of 3000, we successfully achieved a contact angle of degrees on the preliminary modified surface after the excimer lamp irradiation and a contact angle of 30 degrees on the surface further irradiated with ArF excimer laser, whereas the non-treated fluorocarbon resin surface has a contact angle of about 120 degrees.

08/08/2000

http://www.mrs.org/meetings/fall97/abstract_book/N/node36.html

Using UV Irradiation to Bond to Teflon

Linz (FWF) - Fluor polymers, better known as Teflon, can be used in a variety of applications, but they have one serious drawback: they are extremely slippery. This is an advantage in pots and pans, but a problem for science and research. Whether components, pigments or glues - nothing sticks to this material. With the financial assistance of the Austrian Science Fund (FWF), Johannes Heinz from the Johannes Kepler University in Linz has developed a new method, in which laser radiation is used to modify Teflon surfaces and make them sticky.

Everyone knows Teflon and appreciates its benefits. The fields of application range from coatings on frying pans, electrical insulation layers, sliding surfaces and medical inserts to water-repellent textiles. The great advantage of this material is its low chemical reactivity and the extremely low adhesion of liquids to Teflon coatings. But this advantage is also its greatest disadvantage. It has not been possible to modify small, specified areas on fluor polymer surfaces in such a way that glues or metallic coatings stick to them.

This circumstance has limited the use of Teflon substrates in microelectronics, where strong adhesion of contacts is required, or in medical engineering. Heinz achieved the desired effect by irradiating the surface of fluor polymers with UV light of extremely low wavelength, so-called vacuum UV light (172 nm): 'The material is

modified only in those places where it will be glued or coated.

Until now, such modifications were possible only on large surface areas. The chemical reaction takes place only on the surface and the Teflon retains its major property, namely its extremely low adhesion'. The modified materials combine the new surface properties with the desired characteristics of the unmodified residual material, such as excellent electrical insulation for electronics applications, or resistance to aggressive chemicals, or thermal stability.

This is of special advantage in medical engineering, where the application of UV irradiated fluor polymers significantly facilitates the use of artificial blood vessels, grafts, cardiac valves or artificial skin. The new technology ensures tissue adhesion and compatibility on the outer surface, while preventing the blood from clotting on the inner surface. The method is also interesting for the textile industry and the microelectronics industry, where excellent adhesion of metallic objects and contacts is a major prerequisite for any material.

EXHIBIT C

MacLachlan, Julia B

From:

Lipper, Al [alipper@Ushio.com]

Sent:

Monday, September 25, 2000 1:37 PM

To:

jmaclachlan@lof.com

Subject:

Lets try again

Categories: Hydrophobic Removal

Hello Julia:

I sent you a nice e-mail and forgot a few things! It is starting to be one of those days! I hope this one gets to you, and you understand the data. Let me know if you need more information or do not understand anything. The file names have been changed (to protect the innocent), only kidding, but you should be able to figure out which is which.

Pictures in the file

PIC00007 is showing the surface of sample glass. The half of the glass is very wettable and the other half is

hydrophobic which is not irradiated (covered by mask to show the surface difference).

PIC00005 is how I did the irradiation test.

PIC00004 is when the lamp goes on.

Test report is also attached. The title is "Irradiation Test Pilkington Tech.2000" is stating the test result.

Best Regards,

Al Lipper Manager, Systems Sales Dev. Ushio America, Inc. 5740 Cerritos Ave. Cypress, CA 90630 714-229-3172 Phone 714-229-7172 Fax alipper@ushio.com

<<!rradiationTest Pilkingston Tech.Sept.20002.XLS>> <<PIlkington2.JPG>> <<PIlkington1.JPG>> <<Pli>kington.JPG>>

Excimer Irradiation Test

Sample work

1)Silica

Irradiation	Distance	C/	Α		Initial (sample#
20sec.		Г				
	3mm			30	96	P543
Ì	2mm			50	110	P543
	1 mm			24	100	P543
40sec.						
1	1mm	l		14		P543

2)Teflon like (Dark coloured)

Irradiation	Distance	C/A	sample#
0sec		98	P579
30sec	1mm	26	P579
60sec	1mm	10	 P579
90sec	1mm	8	P579

Light source:Excimer Photon source Irradiation Intensity:20mw/cm2 Temperature:27° C

MacLachlan, Julia B

From: Durbin, Janet E

Sent: Wednesday, November 29, 2000 5:08 PM
To: MacLachlan, Julia

To: MacLachlan, Julia
Cc: Durbin, Janet E

Subject: UV treated glass testing, lap shear and tensile

Attached are the test results from the lap shear and tensile samples from the glass coupons that were UV tested. Samples will be in the second drawer in the humidified lab marked "Julia's samples".

Please see me if there are questions.





UVlapshear.xls (21 UVtensile.xls (21 KB) KB)

	nm/minute)	Sample Identification									Failure Mode												
Samples for Julia	per minute (10 n	Sample									Load					#DIN/0i	#DIV/0i						
Samples	test speed = .3937 inches per minute (10 mm/minute)	Sample Identification									Failure Mode												
	test s	Sample									Load					#DIN/0i	#DIV/0i						
C		Sample Identification	mponent adhesive	11/28/2K	1 x 6 glass	3513	ambient	none	24 ambient	11/29/2K	Failure Mode	100ADG	50PG/50AP	glass shattered	glass shattered			UV exposure	ec. UV exposure			All exposure @ 0 mm distance	
INSTRON TESTING	Lap Shear testing	Samp	Essex 2 comp		1				77		Load	215.7	680.7	638.2	816	587.7	259.3	#1 no UV	#2 60 sec.	#3 90 sec.	#4 120 sec.	All exposur	
SNI	Lar		Adhesive and Material	Production Date	Substrate	Substrate Frit	Substrate Temp (F)	Weathering	Conditioning	Test Date		Specimen # 1	Specimen # 2	Specimen # 3	Specimen # 4	Average Load	Std. Dev.	Comments:					

	INSTRON TESTING	ING		TECHNICIA TECHNICIA	TECHNICIAN: J. Durbin	/mimite)
Tensi	Tensile testing	Вl	sbe	speed = .393/ Inches per minute (10 minute)	r minute (10 mir	//minute)
	Sal	Sample Identification	Sampl	Sample Identification	Sample	Sample Identification
	Essex 2 compor	component adhesive				
		11/28/2K				
		3 x 3 glass				
		3513				
		ambient				
		none				
		24 @ ambient				
		11/29/2K				
	Load	Failure Mode	Load	Failure Mode	Load	Failure Mode
	133.2	100ADG				
	932.2	50V*/50ADF				
	542.3	glass shattered/20V*				
	535.9		#DIV/0i		#DIV/0i	
	399.5		#DIV/0!		#DIV/0i	
	#	#1 no IIV exposure				
	#2 60 6	#2 60 soconde IIV expositie				
	#2 00 5#					
	200 24					
	Alle	All exposure @ 0 mm				
	*	adjusted for void				

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